

Docket No.: 0042697.00147US2
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Roy G. GORDON et al.	Confirmation No.:	5616
Application No.:	10/520,456	Art Unit:	2813
Filed:	October 19, 2005	Examiner:	S. McCall Shepard
Title:	VAPOR DEPOSITION OF TUNGSTEN NITRIDE		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT (IDS)

Dear Madam:

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits and before the mailing date of a final Office Action or a Notice of Allowance.

Please charge the \$180.00 fee to our Deposit Account No. 08-0219.

Applicants request that the Examiner initial and return a copy of the enclosed Form PTO SB-08 with the next communication.

Respectfully submitted,

Dated: April 3, 2009

/Yung-Hoon Ha/
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